

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wayne G. Renken
Assignee: SensArray Corporation
Title: Process Condition Sensing Wafer and Data Analysis System
Application No.: 10/685,550 Filing Date: October 14, 2003
Examiner: Charles D. Garber Group Art Unit: 2856
Docket No.: SENS.005US1 Conf. No.: 4924

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I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on February 16, 2005

Helen A. Jackson
Helen A. Jackson

San Francisco, California
February 16, 2005

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF ABANDONMENT

Sir:

Applicant hereby responds to the Notice of Abandonment dated February 7, 2005, in the above-referenced application wherein the Examiner states that a response was never received to the Office Action dated June 29, 2004.

Applicant submits that this notice was sent in error. A timely response was mailed on September 23, 2004. Attached are copies of

1. Return Receipt Postcard date stamped September 27, 2004;
2. Amendment Transmittal; and
3. Amendment in response to June 29, 2004, Office Action (12 pages).

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In view of the above, we respectfully request that the holding of abandonment be withdrawn. If a telephone call would expedite this request, please call Attorney for Applicant shown below at (415) 318-1160.

Respectfully submitted,



Peter A. Gallagher
Attorney for Applicant
Reg. No. 47,584

PARSONS HSUE & DE RUNTZ LLP
655 Montgomery Street, Suite 1800
San Francisco, CA 94111
(415) 318-1160 (main)
(415) 318-1163 (direct)
(415) 693-0194 (fax)